

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: S.V. Sreenivasan et al.	Art Unit	: 1732
Serial No.	: 10/788,700	Examiner	: Matthew J. Daniels
Filed	: February 27, 2004	Conf. No.	: 6995
Title	: FULL-WAFER OR LARGE AREA IMPRINTING WITH MULTIPLE SEPARATED SUB-FIELDS FOR HIGH THROUGHPUT LITHOGRAPHY		

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

In response to the Advisory Action having a mailing date of January 18, 2008,
please amend the above identified application as follows: